

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

MARUYAMA, Kenji et al.

Group Art Unit: 2813

Serial No.: 09/960,296

Examiner: SCHILLINGER, Laura M.

Filed: September 24, 2001

P.T.O. Confirmation No.: 4754

For: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME

INFORMATION DISCLOSURE STATEMENT AND STATEMENT PURSUANT TO 37 CFR 1.97(c)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

September 25, 2003

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449. One copy of each of these documents is attached.

This Information Disclosure Statement is being submitted after issuance of a first official action on the merits and expiration of the three month period following the filing date or the entry in the national stage for the above-captioned application, but prior to issuance of either a final official action, a Notice of Allowance, or an action that otherwise closes prosecution in the application.

The undersigned hereby certifies

XX that each item of information contained in this statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

The above information is presented so that the Patent and Trademark Office may, in the first instance, determine any materiality thereof to the claimed invention. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The Commissioner is authorized to charge Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

Kenneth H. Salen Attorney for Applicant

Reg. No. 43,077

23850

PATENT TRADEMARK OFFICE

KHS/fs

Atty. Docket No. 011267

Suite 1000

1725 K Street, N.W.

Washington, D.C. 20006

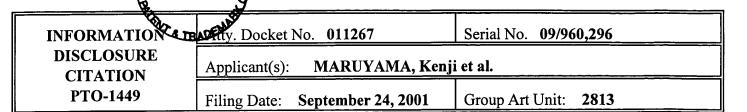
(202) 659-2930

Enclosures: PTO-1449 & 4 references

Korean Office Action dated July 30, 2003

H:\FLOATERS\KHS\01\011267\011267 IDS 9-25-03

2



U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
	AA						
	AB						
	AC						
	AD						
	ΑE						

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
 AF	5-90600	4/ 9/1993	Japan	Yes (Abstract)
 AG	2000-0014388	3/15/2000	Korea	Yes (Abstract)
 АН	1998-079735	11/25/1998	Korea	No (See corresponding Japanese application 10-247664)
 AI AJ	10-247664	9/14/1998	Japan	Yes (Abstract)

OTHER DOCUMENTS

	AK	Korean Office Action dated July 30, 2003
	AL	
Examiner		Date Considered